# WE ARE 心N





# Coupling Defect Centers in Diamond to Fabry-Perot Microcavities

Lilian Childress, McGill University

# **OSA** Technical Groups

Create lasting, valuable connections.

Engaging communities Innovative events Focused networking Enriching webinars

osa.org/technicalgroups



# Technical Group Leadership 2021



**Chair:** <u>Dr. Graciana Puentes</u> University of Buenos Aires, AR



Vice-Chair: Dr. Lee Bassett University of Pennsylvania, US



Events Officer: <u>Dr. Sara Mouradian</u> UC Berkeley, US



Social Media Officer: <u>Dr. Xuejian Wu</u> Rutgers University, US



Liason with Industry: Dr. <u>Mo Soltani</u> Raytheon BBN Technologies, US



# **Our Technical Group at a Glance**

- Experiment, theory, and technologies relevant for quantum measurements and quantum information within the purview of quantum optical science
- Nearly 3000 members worldwide
- Webpage <u>https://www.osa.org/oq</u>
- Webinars, technical events, networking events, campfire sessions etc.
- Suggestions, ideas for events, email us at OSA <u>TGActivities/gpuentes@df.uba.ar</u>
- Upcoming Webinar:
- 31 March 2021
- Prof. Friedemann Reinhard
- The Planar Scanning Probe Microscope: A Novel Platform for Quantum Sensing and Near-Field Microscopy





Welcome to the Quantum Optical Science and Technology Technical Group Webinar!





# Coupling diamond defect centers to high-finesse optical microcavities





# **Motivation: a solid-state spin-photon interface**

# **Quantum networks**



# **Connecting quantum nodes: heralded entanglement**

# The vision:

• A few-spin-qubit register with preparation, coherent control, and measurement

Scalability via optical connections

Spin-photon entanglement Togan et al. 2010 Nature Quantum interference

Coincidence detection → leaves spins entangled Bernien et al 2013 Nature

# **Challenge: efficiency**







![](_page_11_Figure_1.jpeg)

![](_page_12_Figure_1.jpeg)

![](_page_13_Figure_1.jpeg)

![](_page_14_Figure_1.jpeg)

![](_page_15_Figure_1.jpeg)

![](_page_16_Figure_1.jpeg)

Spin-selective transitions

Polarization selection rules

#### BUT:

Only 3% of emission is in ZPL

Dephasing: Detection window needed to render photons indistinguishable

$$\Delta t \sim \frac{1}{\gamma} << \tau$$

![](_page_17_Figure_1.jpeg)

Spin-selective transitions

Polarization selection rules

#### BUT:

Only 3% of emission is in ZPL

Dephasing: Detection window needed to render photons indistinguishable

![](_page_17_Figure_7.jpeg)

# **Connecting quantum nodes: heralded entanglement**

Many protocols require two photon detections for high fidelity

![](_page_18_Figure_2.jpeg)

# To improve efficiency:

- Good photon collection efficiency into single mode
- Enhanced ZPL emission
- Decreased radiative lifetime

**Cavity quantum electrodynamics** 

![](_page_19_Picture_2.jpeg)

$$F_{p} = \frac{3}{4\pi^{2}} \left(\frac{\lambda}{n}\right)^{3} \frac{Q}{V}$$
 Quality factor  
Wode volume

#### **Cavity quantum electrodynamics**

![](_page_20_Picture_2.jpeg)

![](_page_20_Picture_3.jpeg)

PRL 109, 033604 (2012) Also Loncar, Fu, Becher, Barclay, Lukin, Awschalom, Englund, Hu...

$$F_{P} = \frac{3}{4\pi^{2}} \left(\frac{\lambda}{n}\right)^{3} \frac{Q}{V}$$
 Quality factor  
Mode volume

#### **Cavity quantum electrodynamics**

![](_page_21_Picture_2.jpeg)

![](_page_21_Picture_3.jpeg)

PRL 109, 033604 (2012) Also Loncar, Fu, Becher, Barclay, Lukin, Awschalom, Englund, Hu...

Emission on cavity resonance enhanced by  $F_P + 1$ 

 $F_{P} = \frac{3}{4\pi^{2}} \left(\frac{\lambda}{n}\right)^{3} \frac{Q}{V}$  Quality factor Mode volume

### **Diamond nanophotonics**

Promising avenue to enhance ZPL emission fraction and improve collection efficiency

#### **Cavity quantum electrodynamics**

![](_page_22_Picture_2.jpeg)

![](_page_22_Picture_3.jpeg)

PRL 109, 033604 (2012) Also Loncar, Fu, Becher, Barclay, Lukin, Awschalom, Englund, Hu...

**Figure of merit:** cooperativity governs rate of emission of indistinguishable photons via the cavity

$$C = F_P \frac{\gamma_{ZPL}}{\gamma_{ZPL} + \gamma_{PSB} + \gamma_{NR} + \gamma_D}$$

Emission on cavity resonance enhanced by  $F_P + 1$ 

 $F_{P} = \frac{3}{4\pi^{2}} \left(\frac{\lambda}{n}\right)^{3} \frac{Q}{V}$  Quality factor Mode volume

#### **Diamond nanophotonics**

Promising avenue to enhance ZPL emission fraction and improve collection efficiency

#### **Cavity quantum electrodynamics**

![](_page_23_Picture_2.jpeg)

![](_page_23_Picture_3.jpeg)

PRL 109, 033604 (2012) Also Loncar, Fu, Becher, Barclay, Lukin, Awschalom, Englund, Hu...

**Figure of merit:** cooperativity governs rate of emission of indistinguishable photons via the cavity

$$C = F_P \frac{\gamma_{ZPL}}{\gamma_{ZPL} + \gamma_{PSB} + \gamma_R} + \gamma_D$$

Emission on cavity resonance enhanced by  $F_P + 1$ 

 $F_{p} = \frac{3}{4\pi^{2}} \left(\frac{\lambda}{n}\right)^{3} \frac{Q}{V}$  Quality factor Mode volume

#### **Diamond nanophotonics**

Promising avenue to enhance ZPL emission fraction and improve collection efficiency

#### **Cavity quantum electrodynamics**

![](_page_24_Picture_2.jpeg)

![](_page_24_Picture_3.jpeg)

PRL 109, 033604 (2012) Also Loncar, Fu, Becher, Barclay, Lukin, Awschalom, Englund, Hu...

Emission on cavity resonance enhanced by  $F_P$ 

Figure of merit: cooperativity governs rate of emission of indistinguishable photons via the cavity

PRL 109, 033604 (2012)  
Also Loncar, Fu, Becher, Barclay,  
Lukin, Awschalom, Englund, Hu...  
n on cavity resonance enhanced by 
$$F_P + 1$$
  
 $F_P = \frac{3}{4\pi^2} \left(\frac{\lambda}{n}\right)^3 \frac{Q}{V}$  Quality factor  
 $Mode volume$   
 $C = F_P \frac{\gamma_{ZPL}}{\gamma_{ZPL} + \gamma_{PSB} + \gamma_{R} + \gamma_D}$   
 $Optical dephasing rate$ 

#### **Diamond nanophotonics**

Promising avenue to enhance ZPL emission fraction *and* improve collection efficiency

#### **Cavity quantum electrodynamics**

![](_page_25_Picture_2.jpeg)

![](_page_25_Picture_3.jpeg)

PRL 109, 033604 (2012) Also Loncar, Fu, Becher, Barclay,

Lukin, Awschalom, Englund, Hu...

Emission on cavity resonance enhanced by  $F_P$ 

Figure of merit: cooperativity governs rate of emission of indistinguishable photons via the cavity

PRL 109, 033604 (2012)  
Also Loncar, Fu, Becher, Barclay,  
Lukin, Awschalom, Englund, Hu...  
n on cavity resonance enhanced by 
$$F_P + 1$$
  
 $F_P = \frac{3}{4\pi^2} \left(\frac{\lambda}{n}\right)^3 \frac{Q}{V}$  Quality factor  
 $V = F_P \frac{\gamma_{ZPL}}{\gamma_{ZPL} + \gamma_{PSB} + \gamma_{R}} + \gamma_D$   
Optical  
dephasing  
rate

#### **Diamond nanophotonics**

Promising avenue to enhance ZPL emission fraction and improve collection efficiency

#### But...

#### spectral diffusion near surfaces

issue for nanoscale structures

#### **Cavity quantum electrodynamics**

![](_page_26_Picture_2.jpeg)

![](_page_26_Picture_3.jpeg)

PRL 109, 033604 (2012) Also Loncar, Fu, Becher, Barclay, Lukin, Awschalom, Englund, Hu...

Emission on cavity resonance enhanced by  $F_P$ 

Figure of merit: cooperativity governs rate of emission of indistinguishable photons via the cavity

PRL 109, 033604 (2012)  
Also Loncar, Fu, Becher, Barclay,  
Lukin, Awschalom, Englund, Hu...  
n on cavity resonance enhanced by 
$$F_P + 1$$
  
 $F_P = \frac{3}{4\pi^2} \left(\frac{\lambda}{n}\right)^3 \frac{Q}{V}$  Quality factor  
 $Mode volume$   
 $C = F_P \frac{\gamma_{ZPL}}{\gamma_{ZPL} + \gamma_{PSB} + \gamma_{R}} + \gamma_D$   
 $Optical dephasing rate$ 

#### **Diamond nanophotonics**

Promising avenue to enhance ZPL emission fraction and improve collection efficiency

#### But...

#### spectral diffusion near surfaces

issue for nanoscale structures

A single electron fluctuation 100nm away poses problems!

# **Overcoming spectral diffusion**

- Do the hard work
  - Better annealing and fabrication recipes
  - Careful surface science
  - Repeatability...
- Stop using NVs

![](_page_27_Figure_6.jpeg)

Avoid nanofabrication

![](_page_27_Picture_8.jpeg)

PRX 9, 031052 (de Leon group)

#### SiV- defects

- Large ZPL fraction
- Reduced spectral diffusion
- Spin coherence poor above 1K
- Low quantum efficiency Others...?

#### **Cavity quantum electrodynamics**

![](_page_28_Picture_2.jpeg)

![](_page_28_Figure_4.jpeg)

**External**, free-space cavities

#### **Cavity quantum electrodynamics**

![](_page_29_Picture_3.jpeg)

![](_page_29_Figure_5.jpeg)

**External**, free-space cavities

#### **Cavity quantum electrodynamics**

![](_page_30_Picture_3.jpeg)

![](_page_30_Figure_5.jpeg)

**External, free-space cavities** 

**Cavity quantum electrodynamics** 

![](_page_31_Figure_3.jpeg)

number of round trips

![](_page_31_Figure_6.jpeg)

**External**, free-space cavities

**Cavity quantum electrodynamics** 

![](_page_32_Figure_3.jpeg)

![](_page_32_Figure_5.jpeg)

**External**, free-space cavities

**Cavity quantum electrodynamics** 

![](_page_33_Figure_3.jpeg)

Emission on cavity resonance enhanced by

$$F_p = \frac{3}{\pi^3} \frac{\lambda^2}{w_0^2} F$$

Length drops out

External, free-space cavities based on optical fibers

Cavity quantum electrodynamics

![](_page_34_Figure_3.jpeg)

Emission on cavity resonance enhanced by

$$F_p = \frac{3}{\pi^3} \frac{\lambda^2}{w_0^2} F$$

Length drops out

![](_page_35_Figure_1.jpeg)

 $F_p \approx$  few thousand potentially feasible

Emission on cavity resonance enhanced by

$$F_P = \frac{3}{\pi^3} \frac{\lambda^2}{w_0^2} F$$

Length drops out








Tunable cavity with excellent out-coupling for collection efficiency ...and potentially cavity quantum electrodynamics

# Laser ablation:



#### Well-controlled

- laser power
- mode shape
- alignment precision (0.5 microns)

#### Laser-ablated fiber



For  $L \ll ROC$ ,  $F_P \propto 1/\sqrt{ROC}$ 



## Alternate approaches:

**FIB milling** 

Effective ROC down to 4.3  $\mu$ m



Opt. Express 23, 17205717216 (2015) (Smith group) 17205

Combine photolithography with CO<sub>2</sub> laser ablation:



# **Building fiber cavities:**



# **Membrane-in-cavity system**



**Challenges:** 

- High quality NV centers in membranes
- Low membrane scattering and absorption
- Cavity stabilization (at the pm level) in a cryogenic environment

Membrane bonded by van der Waals forces





## I. NVs in membranes

Idea: work with few-micron thick membranes, electron irradiated, sliced, ArCl<sub>2</sub> / O<sub>2</sub> etched



- Single-scan linewidths as low as 25 MHz (TU Delft measurement on our irradiated sample)
- Spectral diffusion ~ 300 MHz (average)

## => Comparable to results in bulk electronic-grade samples

#### More detailed study (TU Delft):



## I. NVs in membranes

Idea: work with few-micron thick membranes, electron irradiated, sliced, ArCl<sub>2</sub> / O<sub>2</sub> etched



- Single-scan linewidths as low as 25 MHz (TU Delft measurement on our irradiated sample)
- Spectral diffusion ~ 300 MHz (average)

## => Comparable to results in bulk electronic-grade samples



Nano Letters 19, 3987 (2019), TU Delft

## I. NVs in membranes

Idea: work with few-micron thick membranes, electron irradiated, sliced, ArCl<sub>2</sub> / O<sub>2</sub> etched



- Single-scan linewidths as low as 25 MHz (TU Delft measurement on our irradiated sample)
- Spectral diffusion ~ 300 MHz (average)

## => Comparable to results in bulk electronic-grade samples down to ~ few μm







• Bulk optical absorption



• Bulk optical absorption negligible



• Surface roughness





• Surface roughness

 $ArCl_2$  etch  $\rightarrow$  as low as 0.2 nm rms



- Bulk optical absorption negligible
- Surface roughness

 $ArCl_2$  etch  $\rightarrow$  as low as 0.2 nm rms

 $\left(\frac{4\pi\sigma}{\lambda}\right)^2 \sim 15 \text{ ppm} \quad << 70 \text{ ppm mirror transmission}$ 





• Surface roughness

 $ArCl_2$  etch  $\rightarrow$  as low as 0.2 nm rms

 $\left(\frac{4\pi\sigma}{\lambda}\right)^2 \sim 15 \text{ ppm} \quad << 70 \text{ ppm mirror transmission}$ 





• Surface roughness

 $ArCl_2$  etch  $\rightarrow$  as low as 0.2 nm rms

 $\left(\frac{4\pi\sigma}{\lambda}\right)^2 \sim 15 \text{ ppm} \quad << 70 \text{ ppm mirror transmission}$ 

• Surface absorption/contamination



# RE

# **II. Membrane losses**

- Bulk optical absorption negligible
- Surface roughness

 $ArCl_2$  etch  $\rightarrow$  as low as 0.2 nm rms

 $\left(\frac{4\pi\sigma}{\lambda}\right)^2 \sim 15 \text{ ppm} \quad << 70 \text{ ppm mirror transmission}$ 

• Surface absorption/contamination seems to be the limiting factor



 $ArCl_2$  etch  $\rightarrow$  as low as 0.2 nm rms

 $\left(\frac{4\pi\sigma}{\lambda}\right)^2 \sim 15 \text{ ppm} \quad << 70 \text{ ppm mirror transmission}$ 

• Surface absorption/contamination seems to be the limiting factor

Distinguishing bulk from surface losses:

**Įt**<sub>d</sub>



• Surface roughness

 $ArCl_2$  etch  $\rightarrow$  as low as 0.2 nm rms

 $\left(\frac{4\pi\sigma}{\lambda}\right)^2 \sim 15 \text{ ppm} \quad << 70 \text{ ppm mirror transmission}$ 

• Surface absorption/contamination seems to be the limiting factor

Distinguishing bulk from surface losses:

**Įt**<sub>d</sub>

ε





- Bulk optical absorption negligible
- Surface roughness

 $ArCl_2$  etch  $\rightarrow$  as low as 0.2 nm rms

 $\left(\frac{4\pi\sigma}{\lambda}\right)^2 \sim 15 \text{ ppm} \quad << 70 \text{ ppm mirror transmission}$ 

 Surface absorption/contamination seems to be the limiting factor

Distinguishing bulk from surface losses:





Distinguishing bulk from surface losses:

Bulk optical absorption negligible

• Surface roughness

 $ArCl_2$  etch  $\rightarrow$  as low as 0.2 nm rms

 $\left(\frac{4\pi\sigma}{\lambda}\right)^2 \sim 15 \text{ ppm} \quad << 70 \text{ ppm mirror transmission}$ 

• Surface absorption/contamination seems to be the limiting factor





• Surface roughness

 $ArCl_2$  etch  $\rightarrow$  as low as 0.2 nm rms

 $\left(\frac{4\pi\sigma}{\lambda}\right)^2 \sim 15 \text{ ppm} \quad << 70 \text{ ppm mirror transmission}$ 

• Surface absorption/contamination seems to be the limiting factor

Distinguishing bulk from surface losses:

**Įt**<sub>d</sub>







• Surface roughness

 $ArCl_2$  etch  $\rightarrow$  as low as 0.2 nm rms

 $\left(\frac{4\pi\sigma}{\lambda}\right)^2 \sim 15 \text{ ppm} \quad << 70 \text{ ppm mirror transmission}$ 

• Surface absorption/contamination seems to be the limiting factor

Distinguishing bulk from surface losses:

**Įt**<sub>d</sub>







• Surface roughness

 $ArCl_2$  etch  $\rightarrow$  as low as 0.2 nm rms

 $\left(\frac{4\pi\sigma}{\lambda}\right)^2 \sim 15 \text{ ppm} \quad << 70 \text{ ppm mirror transmission}$ 

• Surface absorption/contamination seems to be the limiting factor

Distinguishing bulk from surface losses:

**Įt**<sub>d</sub>





## **Membrane losses**

#### Calculation of cavity finesse with

- Diamond Absorption
- Scattering at Diamond-Air Interface
- Mirror Losses
- Scattering at Mirror-Diamond Interface
- Best Guess



Resonant wavelength (nm)

#### Distinguishing bulk from surface losses:





# **Surface losses**

 Improved etching techniques (ArCl<sub>2</sub> + O<sub>2</sub>) => reduced surface losses



- Results inconsistent with AFM results of
  - $\sigma \approx 0.25 \text{ nm-rms}$ 
    - => surface absorption/contamination
- Can now see finesse > 10,000 in diamond-like modes (sometimes)



ε

t

R

The "bad emitter regime:" coupling phonon broadened emission to fiber cavities



# Use to explore cavity coupling to defects in membranes

#### **GeV defects**



- Much larger ZPL fraction ~60%
- Lower spectral diffusion
- Poor spin coherence
- Quantum yield?

Potentially easier to achieve strong coupling than with NVs

#### **GeV defects**



**Experimental setup** 

- Much larger ZPL fraction ~60%
- Lower spectral diffusion
- Poor spin coherence
- Quantum yield?

Potentially easier to achieve strong coupling than with NVs



#### **GeV defects**



**Experimental setup** 

- Much larger ZPL fraction ~60%
- Lower spectral diffusion
- Poor spin coherence
- Quantum yield?

Potentially easier to achieve strong coupling than with NVs



#### **GeV defects**



- Much larger ZPL fraction ~60%
- Lower spectral diffusion
- Poor spin coherence
- Quantum yield?

Potentially easier to achieve strong coupling than with NVs



#### Collaboration with Andersen group, DTU

## **Experimental setup**

#### **GeV defects**



- Much larger ZPL fraction ~60%
- Lower spectral diffusion
- Poor spin coherence
- Quantum yield?

Potentially easier to achieve strong coupling than with NVs



#### Collaboration with Andersen group, DTU

## **Experimental setup**

#### **GeV defects**



- Much larger ZPL fraction ~60%
- Lower spectral diffusion
- Poor spin coherence
- Quantum yield?

Cavity measurements

Potentially easier to achieve strong coupling than with NVs



## **Experimental setup**
#### **GeV defects**



- Much larger ZPL fraction ~60%
- Lower spectral diffusion
- Poor spin coherence
- Quantum yield?

Cavity measurements

Potentially easier to achieve strong coupling than with NVs



#### **Experimental setup**

#### Collaboration with Andersen group, DTU

#### **GeV defects**



- Much larger ZPL fraction ~60%
- Lower spectral diffusion
- Poor spin coherence
- Quantum yield?

Cavity measurements

Potentially easier to achieve strong coupling than with NVs



#### **Experimental setup**

#### Collaboration with Andersen group, DTU



Jensen,\* Janitz,\* et al, Phys. Rev. Applied 2020





#### **Challenge: tunability AND stability at 4K**

- Search for ideal membrane thickness, low loss
- Find "nice" NV

- Locked within ~ few picometers length
- In presence of cryostat noise!

Translation stages are floppy!



Use a closed-cycle cryostat (!?!)

#### Use a closed-cycle cryostat (!?!)

Qlibri platform with active (side of fringe) stabilization below 1 kHz



- < 30 pm-rms during the whole cycle possible,
- ~ 20 pm-rms during "quiet times" (measurements taken with >100 pm-rms)





Commercial cryogenic vibration isolation platform

#### Use a closed-cycle cryostat (!?!)

Observe  $F_P \sim 4 \ (C \sim 0.04)$  for NVs with resonant excitation





Commercial cryogenic vibration isolation platform

Measurements taken with  $\sim 180~\text{pm-rms}$  vibration

Finesse ~ 2000, air-like mode

























Idea: Monitor error signal to measure residual motion (while locked or unlocked)



Idea: Monitor error signal to measure residual motion (while locked or unlocked)



Idea: Monitor error signal to measure residual motion (while locked or unlocked)



Error signal  $\propto$  cavity length

**Compressor off, locked:** 



Idea: Monitor error signal to measure residual motion (while locked or unlocked)



Error signal  $\propto$  cavity length

**Compressor off, locked:** 



Idea: Monitor error signal to measure residual motion



**Compressor off, locked:** 



Idea: Monitor error signal to measure residual motion



### Microcavity residual motion: error signal and transmission



Note:

- in LFGL mode
- at 300K

### Microcavity residual motion: error signal and transmission



#### Microcavity residual motion: error signal and transmission



Surprise #1: Hugely lower vibrations when unlocked ( $\sim 1 \text{ nm-rms} \rightarrow \sim 60 \text{ pm-rms}$ ) Surprise #2: Locking was not particularly helpful



Surprise #1: Hugely lower vibrations when unlocked ( $\sim 1 \text{ nm-rms} \rightarrow \sim 60 \text{ pm-rms}$ ) Surprise #2: Locking was not particularly helpful



Surprise #1: Hugely lower vibrations when unlocked (~ 1 nm-rms  $\rightarrow$  ~ 60 pm-rms) Surprise #2: Locking was not particularly helpful



Surprise #1: Hugely lower vibrations when unlocked ( $\sim 1 \text{ nm-rms} \rightarrow \sim 60 \text{ pm-rms}$ ) Surprise #2: Locking was not particularly helpful



## **Prospects for cooperativity > 1**

#### **Challenge:** Fiber cavity geometry

Riedel et al. PRX **7** 031040 (2017)



ROC =  $16 \,\mu$ m Air gap =  $2 \,\mu$ m

Challenge: NV optical coherence properties

Challenge: Membrane losses

**Challenge:** Vibrations
#### **Challenge:** Fiber cavity geometry

Riedel et al. PRX 7 031040 (2017)



**Challenge:** NV optical coherence properties



ROC =  $16 \,\mu m$ Air gap =  $2 \mu m$ 

 $\gamma_d$  = 86 MHz



### **Challenge:** Fiber cavity geometry

Riedel et al. PRX **7** 031040 (2017)



ROC =  $16 \mu m$ Air gap =  $2 \mu m$ 

Challenge: NV optical coherence properties

### Challenge: Membrane losses



Jensen, Janitz, et al. PRApplied 13 064016 (2020)

 $\gamma_d$  = 86 MHz

Finesse 11,000 in a diamond-like mode

### **Challenge:** Fiber cavity geometry

Riedel et al. PRX **7** 031040 (2017)



**Challenge:** NV optical coherence properties

### Challenge: Membrane losses

**Challenge:** Vibrations



ROC =  $16 \,\mu$ m Air gap =  $2 \,\mu$ m

 $\gamma_d$  = 86 MHz

Finesse 11,000 in a diamond-like mode

### **Challenge:** Fiber cavity geometry

Riedel et al. PRX **7** 031040 (2017)

DBR		SiO <sub>2</sub>
diamond		🗘 0 - 3 μm
DBR	→ ← 1 μm	SiO <sub>2</sub>

Challenge: NV optical coherence properties

Challenge: Membrane losses

Challenge: Vibrations



ROC =  $16 \,\mu$ m Air gap =  $2 \,\mu$ m

 $\gamma_d$  = 86 MHz

Finesse 11,000 in a diamond-like mode

 $\sigma$  = 16 pm-rms



## What's next...

Passive stability is good enough to get started! Experiments ongoing with the same GeV sample

Improved locking: Move to lower finesse wavelength for locking light Stiffen/dampen the tripod support

#### Yet better membranes:

Need to understand loss mechanisms and systematically explore mitigation approaches

#### Goal:

Combine improved stability + lower-loss membranes + "nice" defects to aim for C > 1

### Thanks to ....



Loncar lab: Pawel Latawiec, Srujan Meesala Lukin lab: Mihir Bhaskar, Ruffin Evans (Harvard University)



Sankey lab: Tina Muller, Alex Bourrassa Andersen lab: Rasmus Jensen (DTU) Western Digital: Pat Braganca

FONDATION CANADIEN

de recherche du Canada

Canada Research Chairs



...and you for your attention